

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Bradley J. Aitchison et al.

Confirmation No. 5483

Application No. 10/660,365

Filed: September 10, 2003

For: **PRECURSOR MATERIAL
DELIVERY SYSTEM FOR ATOMIC
LAYER DEPOSITION**

Group Art Unit: 1724

Examiner: Jason M. Greene

Attorney Docket No. 11429/12:2

Date: April 11, 2006

AMENDMENT

TO THE COMMISSIONER FOR PATENTS:

In response to the January 25, 2006 Office action, please amend the above-identified patent application as follows.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 6 of this paper.